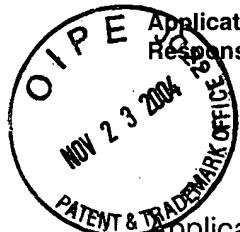


EV372471501

MI22-1544



Application Serial No. 09/677,478  
Response to October 26, 2004 NOA

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 09/677,478  
Filing Date ..... October 2, 2000  
Inventor ..... Guy T. Blalock  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 1765  
Examiner ..... Lan Vinh  
Attorney's Docket No. .... MI22-1544  
Title: Plasma Etching Methods

**RESPONSE TO OCTOBER 26, 2004 NOTICE OF ALLOWANCE**  
**TO ACCOMPANY REQUEST FOR CONTINUED EXAMINATION**

To: Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

From: D. Brent Kenady  
Tel. 509-624-4276; Fax 509-838-3424  
Wells St. John P.S.  
601 W. First Avenue, Suite 1300  
Spokane, WA 99201-3828

Sir:

Responsive to the Notice of Allowance dated October 26, 2004,  
Applicant amends and remarks as follows:

Underlines indicate insertions and ~~strikeouts~~ indicate deletions.